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***IN THE UNITED STATES PATENT AND TRADEMARK OFFICE***

In re application of: Cho et al.

Atty Docket No.:  
NOVLP089/NVLS-2886/2887

Application No.: 10/800,377

Examiner: Picardat, Kevin M.

Filed: March 11, 2004

Group: 2822

Title: METHOD AND APPARATUS FOR UV  
EXPOSURE OF LOW DIELECTRIC  
CONSTANT MATERIALS FOR POROGEN  
REMOVAL AND IMPROVED MECHANICAL  
PROPERTIES

**CERTIFICATE OF FACSIMILE TRANSMISSION**

I hereby certify that this correspondence is being transmitted by  
facsimile to fax number 571-273-8300 to the U.S. Patent and  
Trademark Office on December 1, 2006.

Signed: \_\_\_\_\_

Tara Hayden

**SUPPLEMENTAL AMENDMENT AFTER ALLOWANCE, BEFORE  
PAYMENT OF ISSUE FEE  
PURSUANT to 37 C.F.R. §1.312 (a)**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

This Amendment is intended to replace the Amendment filed on November 29, 2006.  
Kindly amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Remarks appear on page 3 of this paper.

OK  
TO  
ENTER  
3/6/07  
74P